

New Patent Claim 1

1. X-ray anode for microfocus sources in which the anode material is located on a diamond window, characterized in that the thickness of the diamond window is in the range of 300 μm to 2000 μm .

This is followed by the currently valid patent claims 2 through 16.

as a temperature sensor.

15. Use of an x-ray anode according to at least one of claims 1 through 14 for x-ray microscopes.
16. Use of an x-ray anode according to at least one of claims 1 through 14 for x-ray units.

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